

**IN THE UNITED STATES PATENT & TRADEMARK OFFICE**

Application Number : 10/527,056 Confirmation No. 6957  
Applicant : Woo-Seok CHEONG et al.  
Filed : October 20, 2005  
Tech Cntr/AU : 1792  
Examiner : Nathan K Ford  
Entitled : APPARATUS FOR MANUFACTURING  
SEMICONDUCTOR DEVICE AND METHOD FOR  
MANUFACTURING SEMICONDUCTOR DEVICE BY  
USING THE SAME  
  
Attorney Reference : 123034-05029639  
Customer Number : 22429

**MAIL STOP AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

**RESPONSE TO RESTRICTION/ELECTION REQUIREMENT**

Sir:

In response to the Restriction/Election Requirement set forth in the Office Action mailed April 29, 2008, Applicant elects Group II (claims 6-14) drawn to a method for manufacturing a semiconductor apparatus, with traverse.

Applicant respectfully traverses the restriction/election requirement. The claims of Group II (claims 6-14) drawn to a method for manufacturing a semiconductor apparatus and the claims of Group I (claims 1-5) drawn to an apparatus for manufacturing semiconductor device are closely related to each other and define a single invention. Further, Applicant respectfully submits that it would not be unduly burdensome for the Examiner to examine the claims of three groups. Applicant respectfully requests that claims **1-14** be examined.

An early Office Action on the merits is respectfully requested.

To the extent necessary, a petition for an extension of time under 37 C.F.R. 1.136 is hereby made. Please charge any shortage in fees due in connection with the filing of this paper,

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*May 27, 2008*

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including extension of time fees, to Deposit Account 07-1337 and please credit any excess fees to such deposit account.

Respectfully submitted,  
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